

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/708,320	LEE, JEN-FENG	
Examiner	Art Unit	
Kim R. Lockett	2837	

SEARCHED						
Class	Subclass	Date	Examiner			
84	173-179					
	183					
	453					
372	333					
	321					
	328					
292	dis.zx	3/3/05	w			
	·					

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
600m/0	0					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
·				
		, ,		